# **Development of self-doped PEDOT/Si hybrid solar cells**

## Introduction

Silicon-Organic Hybrid Solar Cell (SOHC)



• High efficiency (~17%)[1] • Low material cost Easy fabrication Low temperature

## Easy to recycle

processes (>300°C)

Challenges



Growth of SiO, Poor junction Defects in interface interlayer [2] PEDOT:PSS layer



## This Work

## MgF<sub>2</sub> AR layer S-PEDOT Oxide laver n-Si n<sup>+</sup> BSF layer Au-Sb/Au

Schematic of SOHC fabricated in this study

#### Aim:

To improve the durability of SOHCs through a combination of high-quality passivation layer and a novel self-doped

### Self-doped PEDOT (S-PEDOT) [3]

- Soluble in water
- Better conformality to nano structures
- Less void defects in thin film
- Similar conductivity to PEDOT:PSS
  - S-PEDOT Structure

S-PEDOT

-SO<sub>3</sub>H

-SO<sub>3</sub>H

- Neutral Beam Oxide (NBO) Layer [4]
- Room temperature process
- >95% pure  $SiO_2$
- 3 nm thin layers in 300 s
- Defect free SiO<sub>2</sub> layer
- Neutral Beam

## **Device Fabrication**



## **Results and Discussion**

#### Dependence of PV characteristics on NBO film thickness Durability of measured solar cell samples 25 25 • 1 nm thermal oxide interlayer may 1.1 nm Thermal Oxide 0.4 20 a 2 20 <sub>2</sub> perform better but NBO layers of the NBO (1.4 nm) 1.4 nm 20 (1 nm)



- same thickness show better consistency over multiple samples.
- Oxide interlayers with the highest oxygen saturation (i.e. highest percentage of  $SiO_2$ ) show the least degradation in photovoltaic performance.
- S-shaped *J-V* curve develops within the first week of storage pointing possible loss in PEDOT carrier concentration

Table for the thickness and saturation of the interlayers:

Preparation	Thickness (nm)	Oxygen Saturation (%)
NBO for 400 s	4.6	95
30 s HF etch after NBO	1.4	83
40 s HF etch after NBO	1.0	43
50 s HF etch after NBO	0.50	55
150 °C for 15 min	1.0	54



## Summary

• We fabricated simple planar silicon-organic hybrid solar cells (SOHCs) using a new self-doped PEDOT, which overcomes some of the limitations of PEDOT:PSS. The best performing cells achieved an efficiency of 6.35% with 482 mV in  $V_{OC}$  and 21.99 mA/cm<sup>2</sup> in  $J_{SC}$  for a cell with a 1 nm-thick

0.6

0.6

0.5

0.5

Durability of (a) J<sub>SC</sub>, (b) FF, and (c) V<sub>OC</sub> of the TO1 (thermal oxide), NO1 (NBO 1.4 nm), NO2 (NBO 1.0 nm), and NO3 (NBO 0.5 nm) samples over time.

interfacial oxide layer.

• Two probable degradation mechanisms caused the development of s-shaped J–V responses:

- (i) reaction of S-PEDOT with unsaturated silicon sub-oxides
- (ii) the degradation of S-PEDOT over time.
- The use of a thin, homogeneous, and highly saturated silicon oxide layer using neutral beam oxidation (NBO) proved effective against mitigating the first factor.

3. Hirokazu Yano et al., Sci. Adv., 2019, 5, eaav9492.

**References:** 

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4. Seiji Samukawa, Jpn. J. Appl. Phys., 2006, 45, 2395.

Aditya Saha<sup>1</sup>、大島隆治<sup>2</sup>、大堀大介<sup>1</sup>,佐々木孝彦<sup>2</sup>、箭野裕一<sup>3</sup>,奥崎秀典<sup>4</sup>、菅谷武芳<sup>2</sup>、 德增崇<sup>1</sup>、遠藤和彦<sup>1</sup>、寒川誠二<sup>1</sup> 2. 産業技術総合研究所 ゼロエミッション国際共同研究センター 1. 東北大学 4. 山梨大学 3. 東ソー(株)



